



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2851

00862.022151.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|                                      |   |                        |
|--------------------------------------|---|------------------------|
| In re Application of:                | ) |                        |
|                                      | : | Examiner: H. Nguyen    |
| Masaya OGURA et al.                  | ) |                        |
|                                      | : | Group Art Unit: 2851   |
| Application No.: 09/811,419          | ) |                        |
|                                      | : | Confirmation No.: 9530 |
| Filed: March 20, 2001                | ) |                        |
|                                      | : |                        |
| For: EXPOSURE APPARATUS, METHOD OF ) |   | April 29, 2004         |
| MANUFACTURING SEMICONDUCTOR :        |   |                        |
| DEVICES AND PLANT THEREFOR )         |   |                        |

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated January 29, 2004, please amend the above-identified application as follows, pursuant to 37 C.F.R. § 1.116:

Do not  
enter  
5/7/04  
HN